

Notice of References Cited	Application/Control No. 10/656,879	Applicant(s)/Patent Under Reexamination HATANO ET AL.	
	Examiner Leo Boutsikaris	Art Unit 2872	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,933,504	01-1976	Phillips et al.	430/2
	B	US-6,373,806	04-2002	Kitamura et al.	369/103
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	L.Galampos et al., "Doubly doped stoichiometric annd congruent lithium niobate for holographic data storage", Journal Crystal Growth, 229, pp. 228-232(2001)
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.